



IPW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79882

Yasuaki TSUCHIYA, et al.

Appln. No.: 10/777,089

Group Art Unit: 1755

Confirmation No.: 4112

Examiner: Michael A. MARCHESCHI

Filed: February 13, 2004

For: CHEMICAL MECHANICAL POLISHING SLURRY

SUPPLEMENTAL AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

An Amendment fully responsive to the Office Action dated May 9, 2005 was filed on September 6, 2005, with a petition for a one-month extension of time.

Please further amend the above-identified application as follows on the accompanying pages.

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